


<b>Search Notes</b>  	<b>Application/Control No.</b>  10539794	<b>Applicant(s)/Patent Under Reexamination</b>  KIM, JAE HEUN
	<b>Examiner</b>  Nicholas D Rosen	<b>Art Unit</b>  3625

SEARCHED			
Class	Subclass	Date	Examiner
705	14.4, 14.51, 26, 27	3/2/2010	NDR

SEARCH NOTES		
Search Notes	Date	Examiner
EIC search results	2/23/2010	NDR
WEST keyword search	3/2/2010	NDR

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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